



△				APPROVED	CHECKED	MATERIAL 材料	-	CHAMFER 一般面取	-	QUANTITY 个数	
△				S. U.	S. U.	TREATMENT 処理	-	FINISHING 仕上	-	-	
△						TREATMENT CONTACT 処理接点	-	DECENTRATION 偏芯	-		
△				DESIGNED	DRAWN	OVER 250 UP TO 1000	±0.3 ±0.5 ±1.0 ±0.2	ANGLE 角度	METHOD 図法	REMARK 適用 (機種名)	
△				M. K.	M. Y.	OVER 63 UP TO 250	±0.2 ±0.3 ±0.6 ±0.15	UNIT (mm)	-	SV-GA430	
△						OVER 16 UP TO 63	±0.1 ±0.2 ±0.4 ±0.1				SCALE
	DATE	EXCH NO.	REVISION 変更記事			TOLERANCES	(A) B C S	DATE	15.07.15	DRAW NO.	0 D F L 0 0 3 3 A 1